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| SERIAL NUMBER 10/500,268 | FILING OR 371(c) DATE 06/23/2004 RULE | CLASS 117 | GROUP ART UNIT 1765 | ATTORNEY DOCKET NO. 92372 | |
| APPLICANTS Masahiko Ando, Kanagawa, JAPAN; Masaru Yuyama, Kanagawa, JAPAN; Shiro Yoshino, Kanagawa, JAPAN; | | | | | |
| ** CONTINUING DATA ***** This application is a 371 of PCT/JP02/13477 12/25/2002 | | | | | |
| ** FOREIGN APPLICATIONS ***** JAPAN 2001-394791 12/26/2001 | | | | | |
| Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and Acknowledged _____ Examiner's Signature Initials | | STATE OR COUNTRY JAPAN | SHEETS DRAWING 20 | TOTAL CLAIMS 20 | INDEPENDENT CLAIMS 10 |
| ADDRESS Welsh & Katz 120 South Riverside Plaza 22nd Floor Chicago ,IL 60606-3913 | | | | | |
| TITLE Method for vanishing defects in single crystal silicon and single crystal silicon | | | | | |
| FILING FEE RECEIVED 1522 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit | | |